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REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2815
PATENT
3430-0131P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S) : HWANG, Kwang-Jo CONF. : 5562
SERIAL NO.: 09/648,111 GROUP: 2815
FILED: August 25, 2000 EXAMINER: BROCK II, P.
FOR: METHOD OF PATTERNING A METAL LAYER IN A SEMICONDUCTOR DEVICE

LARGE ENTITY TRANSMITTAL FORM
FOR REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 3, 2004

Sir:

Transmitted herewith is an amendment in the above-identified application.

The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
 The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NUMBER PREVIOUSLY PAID FOR			PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	30	-	30	=	0	\$ 18	\$ 0.00
INDEPENDENT	4	-	4	=	0	\$ 88	\$ 0.00
<input type="checkbox"/> FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM						\$300	\$ 0.00
						TOTAL	\$ 0.00

- Petition for () month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.
- No fee is required.
- Check(s) in the amount of \$0.00 is(are) enclosed.
- Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By 
Joseph A. Kolasch, #22,463

JAK/*PLS*/ags

P.O. Box 747
Falls Church, VA 22040-0747
(703) 205-8000

Attachment(s)



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AMENDMENT UNDER 37 C.F.R. § 1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 3, 2004

Dear Sir:

In response to the Final Office Action dated August 5, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes Amendments to the Claims and Remarks.